

**The 9th International Conference of Asian Society for
Precision Engineering and Nanotechnology**

Presented

Best Paper Award

**Optical Depth Measurement for Microgrooves: A Self-interferometry Method based
on Near-field Polarization Analysis**

Yizhao Guan, Shuzo Masui, Shotaro Kadoya, Masaki Michihata and Satoru Takahashi
The University of Tokyo

**This person is the winner of the Best Paper Award granted on the occasion of the 9th International
Conference of Asian Society for Precision Engineering and Nanotechnology held in Singapore**

November 17, 2022



President of ASPEN
A. Senthil Kumar

